

Electronic Filing System (EFS) Data  
Electronic Patent Application Submission  
USPTO Use Only

EFS ID: 15333  
Application ID: 10063869  
Title of Invention: INSPECTION METHOD AND  
INSPECTION APPARATUS FOR  
SEMICONDUCTOR CIRCUIT  
First Named Inventor: Chihiro Araki  
Domestic/Foreign Application: Domestic Application  
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Payment Category: CC - Credit Card  
Credit Card Number: \*\*\*\*\*2005  
Expiration Date: 12312002  
Card Holder Name: Ernest A Beutler Attorne  
RAM User ID: EFSPROD  
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Customer Number Attorney: 025776



Customer Number Correspondence Address: 025776



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## INVENTOR(s):

Primary Citizenship: JAPAN

Given Name: Chihiro

Family Name: Araki

Residence City: Shuuchi-gun

Residence Country: JP

Address: c/o 1450-6 Mori

Shuuchi-gun , JP